



PATENT
Attorney Docket No.: SAM-0465
Customer No.: 29344

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Kyung-soo Kim, *et al.* Examiner: Chen, Kin Chan
Serial No.: 10/685,738 Group Art Unit: 1765
Filing Date: October 15, 2003
Title: METHOD FOR MANUFACTURING MULTI-THICKNESS GATE
DIELECTRIC LAYER OF SEMICONDUCTOR DEVICE

CERTIFICATE OF MAILING UNDER 37 C.F.R. § 1.8

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11905
Date

Vanessa Marakas

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

TRANSMITTAL LETTER

Sir:

Enclosed herewith for filing in the above-identified patent application please find the following listed items:

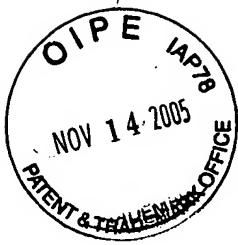
1. Amendment After Final Rejection in response to Office Action mailed on September 14, 2005; and
2. Return Postcard

In connection with the foregoing matter, please charge any additional fees which may be due, or credit any overpayment, to Deposit Account Number 50-1798. A duplicate copy of this letter is provided for this purpose.

Respectfully submitted,

Date: November 9, 2005
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Attorney Docket No.:SAM-0465
Application Serial No.: 10/685,738
Reply to Office Action of: September 14, 2005

AF
JRW

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Date

Vanessa Marakas

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Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT AFTER FINAL

Sir:

The following is in response to the Office Action dated September 14, 2005, and is filed within the shortened statutory period of three months. Please amend the application as follows.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 6 of this paper.